



**ELECTRONIC COPY**

LG651493762  
Report verification at igi.org



September 12, 2024

IGI Report Number **LG651493762**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **5.48 X 5.22 X 3.88 MM**

**GRADING RESULTS**

Carat Weight **1.03 CARAT**

Color Grade **D**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

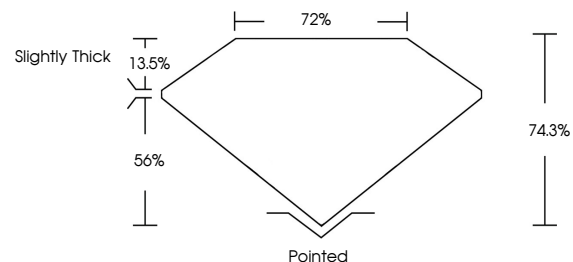
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG651493762**

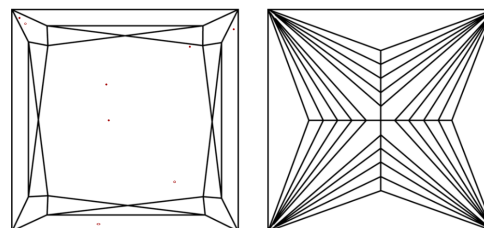
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

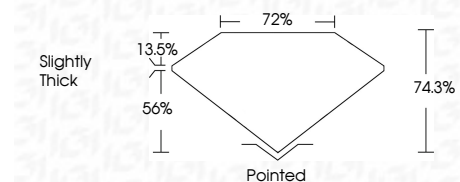
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No LG651493762  
**PRINCESS CUT**

**1.03 CARAT**  
D

**5.48 X 5.22 X 3.88 MM**

Carat Weight  
Color Grade  
Clarity Grade  
Table  
Girdle  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

**VS 1**  
**74.3%**  
**72%**  
Slightly Thick

Pointed  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
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